

Title: ELECTRON BEAM
EXPOSURE APPARATUS AND
EXPOSURE METHOD
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DOCKET NO.: 039262-0149

FIG. 1

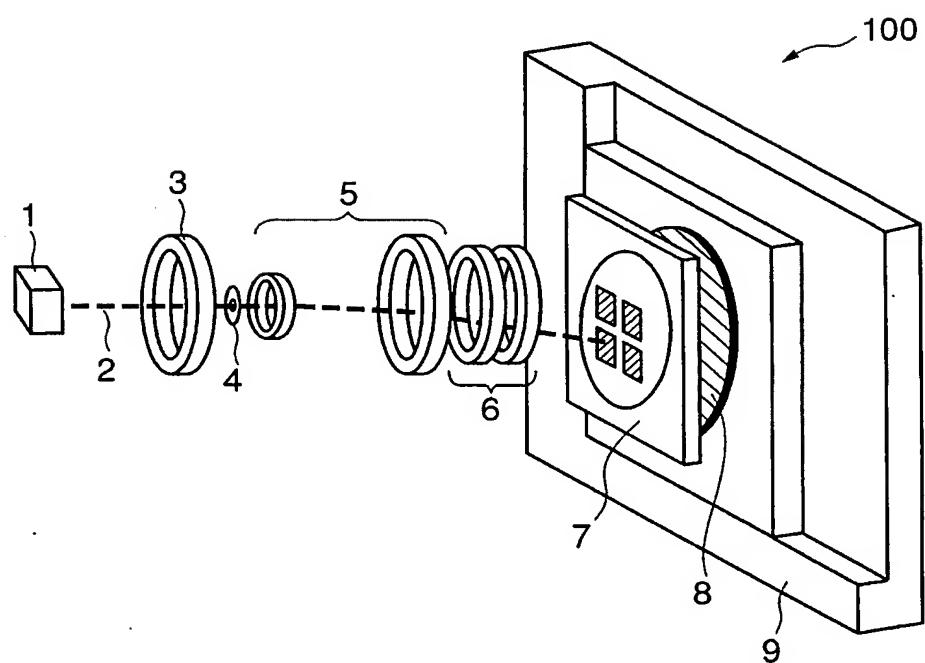


FIG. 2

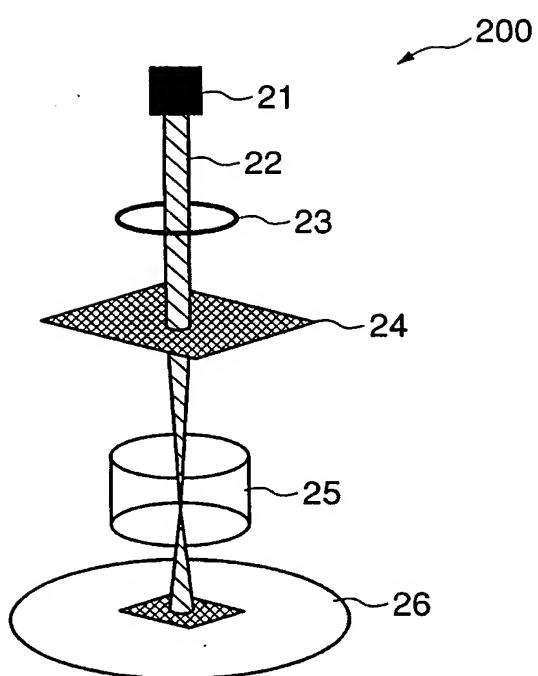


FIG. 3

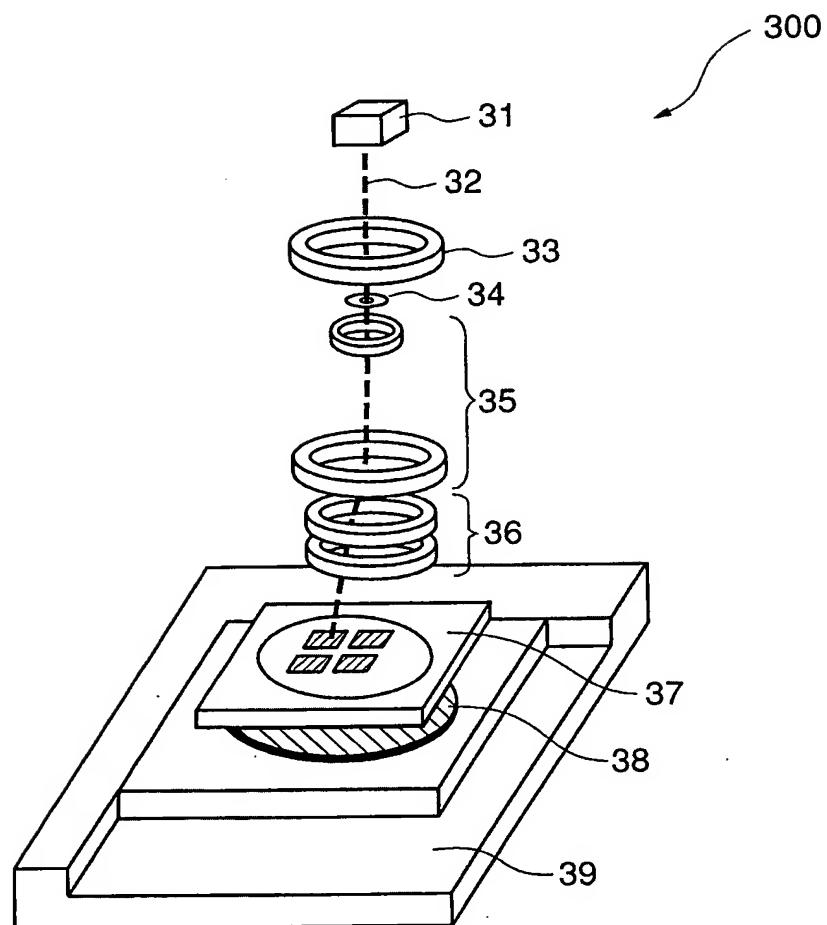


FIG. 4

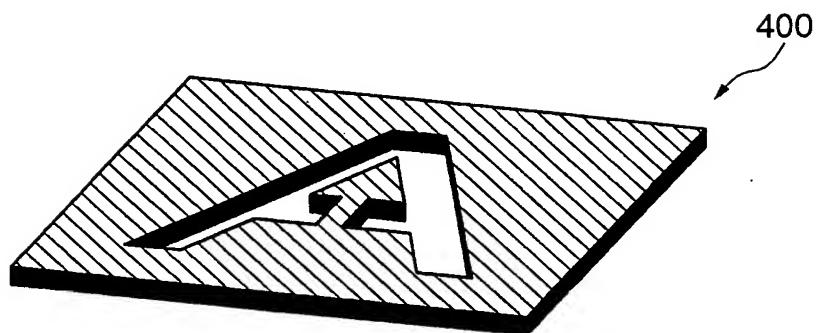


FIG. 5

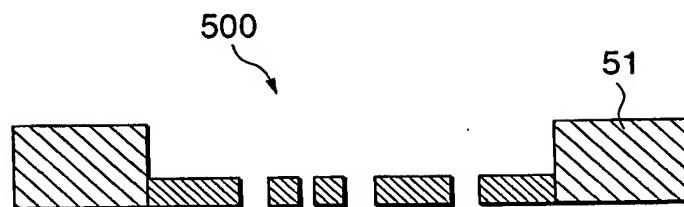


FIG. 6

